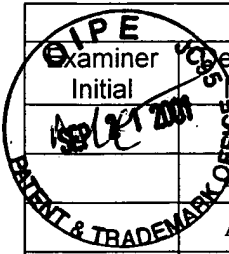


Substitute Form PTO-1449 (Modified)	U.S. Department of Commerce Patent and Trademark Office	Attorney's Docket No. 05918-083002	Application No. 09/745,786
Information Disclosure Statement by Applicant (Use several sheets if necessary) (37 CFR §1.98(b))		Applicant Thomas G. Lacey, et al.	
		Filing Date December 21, 2000	Group Art Unit 3626


U.S. Patent Documents							
Examiner Initial	Desig. ID	Patent Number	Issue Date	Patentee	Class	Subclass	Filing Date If Appropriate
	5A	5,385,706	Jan. 31, 1995	Thomas, Dennis A.			
	5B						
	5C						
	5D						
	5E						
	5F						
	5G						
	5H						
	5I						
	5J						
	5K						

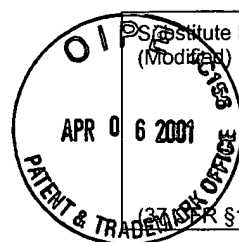
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Foreign Patent Documents or Published Foreign Patent Applications								
Examiner Initial	Desig. ID	Document Number	Publication Date	Country or Patent Office	Class	Subclass	Translation	
							Yes	No
	AL							
	AM							
	AN							
	AO							
	AP							

Other Documents (include Author, Title, Date, and Place of Publication)		
Examiner Initial	Desig. ID	Document
	AQ	
	AR	
	AS	
	AT	

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Examiner Signature 	Date Considered 20/Jun/83
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 Substitute Form PTO-1449
 (Modification)

 U.S. Department of Commerce
 Patent and Trademark Office

 Attorney's Docket No.
 05918-083002

 Application No.
 09/745,786

**Information Disclosure Statement
 by Applicant**

(Use several sheets if necessary)

 Applicant
 Thomas G. Lacey, et al.

 Filing Date
 December 21, 2000

Group Art Unit

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Examiner Initial	Desig. ID	Patent Number	Issue Date	Patentee	Class	Subclass	Filing Date If Appropriate
MC	AA	3,312,583	04/04/1967	Rochlis	161	62	
MC	AB	3,507,010	04/21/1970	Doleman et al.	18	21	
MC	AC	3,557,407	01/26/1971	Lemelson	18	10	
MC	AD	3,590,109	06/29/1971	Doleman et al.	264	167	
MC	AE	3,752,619	08/14/1973	Menzin et al.	425	134	
MC	AF	3,758,657	09/11/1973	Menzin et al.	264	166	
MC	AG	3,762,000	10/02/1973	Menzin et al.	24	204	
MC	AH	4,162,757	07/31/1979	Lemelson	228	1 R	
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MC	AM	5,077,870	01/07/1992	Melbye et al.	24	452	
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MC	AR	5,235,731	08/17/1993	Anzai et al.	24	576	
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MC	AW	5,339,499	08/23/1994	Kennedy et al.	24	452	
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MC	AAA	5,538,674	07/23/1996	Nisper et al.	264	1.31	

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201 Jan 103

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Substitute Form PTO-1449 (Rev. 5-2000)	U.S. Department of Commerce Patent and Trademark Office	Attorney's Docket No. 05918-083002	Application No. 09/745,786
Information Disclosure Statement by Applicant (Use several sheets if necessary) (37 CFR § 1.98(b))		Applicant Thomas G. Lacey, et al.	
		Filing Date December 21, 2000	Group Art Unit

U.S. Patent Documents

Examiner Initial	Desig. ID	Patent Number	Issue Date	Patentee	Class	Subclass	Filing Date If Appropriate
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MC	ADD	5,692,271	12/02/1997	Provost et al.	24	452	
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MC	AFF	5,900,350	05/04/1999	Provost et al.	430	325	06/06/1996
MC	AGG	5,945,131	08/31/1999	Harvey et al.	425	141	04/16/1997
MC	AHH	5,971,738	10/26/1999	Jens et al.	425	194	01/21/1997
MC	AII	6,039,556	03/21/2000	Jens et al.	425	363	09/10/1997
	AJJ						

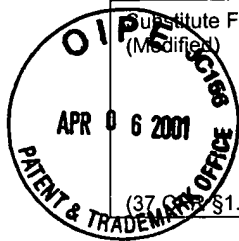
Foreign Patent Documents or Published Foreign Patent Applications

Examiner Initial	Desig. ID	Document Number	Publication Date	Country or Patent Office	Class	Subclass	Translation	
							Yes	No
MC	AKK	EP 0 464 754 A1 ✓	07/01/1991	EPO				
MC	ALL	EP 0 698 351 A2 ✓	08/24/1995	EPO				
MC	AMM	EP 0 714 614 A1 ✓	11/27/1995	EPO				
MC	ANN	GB 2 296 423 ✓	03/26/1997	UK				
MC	AOO	WO 94/23610 ✓	10/27/1994	WIPO				
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MC	ASS ✓	"What is the Photo Chemical Machining Process and What Can It Do For You?", <i>Photo Chemical Machining Institute</i> -San Clemente, CA
MC	ATT ✓	Bennett, R.J., "Photo-Chemical Machining Fundamentals-With Three Unique Applications", <i>Technical Paper</i> , Creative Manufacturing Engineering Programs, Society of Manufact. Engineers, Dearborn, Michigan, 1976

Examiner Signature <i>M. E. Lacey</i>	Date Considered 201 Jan 03
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 Substitute Form PTO-1449
 (Modified)

 U.S. Department of Commerce
 Patent and Trademark Office

 Attorney's Docket No.
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 Application No.
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**Information Disclosure Statement
 by Applicant**

(Use several sheets if necessary)

(37 CFR § 1.98(b))

 Applicant
 Thomas G. Lacey, et al.

 Filing Date
 December 21, 2000

Group Art Unit

Other Documents (include Author, Title, Date, and Place of Publication)

Examiner Initial	Desig. ID	Document
MO	AUU ✓	Freeman, H. "Manufacturing Metal Parts by the Photo-Chemical Machining Process", Conference Proceedings, Nontraditional Machining, Cincinnati, Ohio, 2-3 Dec. 1985, Carl Wegner, Chairman
MC	AVV ✓	Han et al, Micromechanical Velcro, J. of Micromechanical Systems, vol. 1 pp. 37-43, 1992
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Examiner Signature

Date Considered

2013m/03

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